

Electronic Acknowledgement Receipt

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International Application Number:	
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Title of Invention:	Plasma processing system and its substrate processing process, plasma enhanced chemical vapor deposition system and its film deposition process
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
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1		263788USRCE.pdf	83798 67203cc0e83ae0c723719ff0db7d731b bc341578	yes	2
	Multipart Description/PDF files in .zip description				
	Document Description		Start	End	
	Request for Continued Examination (RCE)		1	1	
	Extension of Time		2	2	
Warnings:					
Information:					
2	Fee Worksheet (PTO-06)	fee-info.pdf	8397 958b31c30f1dde1b24e8d83c3f108731 10e5dfc5	no	2
Warnings:					
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Total Files Size (in bytes):			92195		
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